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CofC

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

HIROKAZU OTOSHI ET AL.

Appln. No.: 10/627,603

Filed: July 28, 2003

For: APPARATUS AND METHOD FOR
FORMING DEPOSITED FILM

U.S. Patent No.: 7,001,640 B2

Issued: February 21, 2006

) : Examiner: David P. Turocy

) : Art Unit: 1762

Certificate

JUN 3 0 2006

of Correction

) : June 14, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

The following minor errors have been noted in the above-mentioned patent:

ON COVERPAGE AT (56) FOREIGN PATENT DOCUMENTS

“JP 79-1622 1/1979” should read --JP 54-1622 1/1979--.

ON COVERPAGE AT (57) ABSTRACT

Line 21, “pressure-gauge” should read --pressure gauge--.

COLUMN 22

Line 22, “woundn” should read --wound--.

These errors appear to be relatively insignificant and, therefore, we do not believe it is necessary to request a Certificate of Correction. However, it is requested that this paper be placed in the filewrapper of the above-identified patent.

Patentees' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Peter Saxon
Peter Saxon
Attorney for Patentees
Registration No. 24,947

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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